

					PATENT NUMBER
Subclass	Class	ISSUE CLASSIFICATION	BEST AVAILABLE COPY		
U.S. UTILITY Patent Application					
 DOL SCANNED 			O.I.P.E.	PATENT DATE	
APPLICATION NO.	CONT/PRIOR	CLASS	SUBCLASS	ART UNIT	EXAMINER
09/605293		257	347	2811 2815	<i>Richards</i>
APPLICANT'S TITLE	DAVID L. CHAPEK				
TITLE	METHOD FOR CONTROLLING THE MORPHOLOGY OF DEPOSITED SILICON ON A SILICON DIOXIDE SUBSTRATE AND SEMICONDUCTOR DEVICES INCORPORATING SUCH DEPOSITED SILICON				
PTO-2040 12/99					

ISSUING CLASSIFICATION

TERMINAL DISCLAIMER	DRAWINGS			CLAIMS ALLOWED	
	Sheets Drwg.	Figs. Drwg.	Print Fig.	Total Claims	Print Claim for O.G.
<input type="checkbox"/> The term of this patent subsequent to _____ (date) has been disclaimed.				(Assistant Examiner)	(Date)
<input type="checkbox"/> The term of this patent shall not extend beyond the expiration date of U.S Patent No. _____				(Primary Examiner)	(Date)
<input type="checkbox"/> The terminal _____ months of this patent have been disclaimed.				(Legal Instruments Examiner)	(Date)
NOTICE OF ALLOWANCE MAILED					
ISSUE FEE					
Amount Due		Date Paid			
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